



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Li et al.

Patent No.: 7,041,599

Issued: May 9, 2006

Serial No.: 09/469,709

Filed: December 21, 1999

For: HIGH THROUGH-PUT CU

> CMP WITH SIGNIFICANTLY REDUCED EROSION AND

DISHING

Certificate of Correction Branch Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

999999

Group Art Unit: 1763

Examiner:

George A.

Goudreau

999999999

CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on 2/27, 2006 with the United States Postal Service as First Class Mail in an envelope addressed to: Certificate of Correction Branch, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Dear Sir:

REQUEST FOR CERTIFICATE OF CORRECTION

Attached is a Certificate of Correction for correcting several errors throughout the printed patent.

Applicants submit that at least one of the errors mentioned above was made by the applicants. Therefore, please charge the fee of \$100.00 to deposit account no. 20-0782/APPM/3786.Y1 (KMT).

Respectfully submitted,

Keith M. Tackett

Registration No. 32,008

PATTERSON & SHERIDAN, L.L.P. 3040 Post Oak Blvd. Suite 1500

Houston, TX 77056

Telephone: (713) 623-4844 Facsimile: (713) 623-4846

Agent for Applicant(s)

C2/C1/2008 HBUTEMAL G0000016 200702 7042559

VI 7081611 100.09 09.

486098_1

atig 03 2006

UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO.: 7,041,599

Page <u>1</u> of <u>1</u>

APPLICATION NO.: 09/469,709

DATED: May 9, 2006

INVENTOR(S): Shijian LI, Fred C. REDEKER, John WHITE, Ramin EMAMI

It is certified that error appears in the above-identified patent and that said Letters Patent are hereby corrected as shown below:

In the Specification

Column 1, Line 47: Change "(w)" to --(W)--

Column 3, Line 9: Change the semicolon to a comma

Column 3, Line 29: Change "particular" to --particularly--

Column 5, Line 47: Before "interlayer", change "a" to --an--

Column 6, Line 37: Change "iminodiaetic" to --iminodiacetic--

Column 7, Line 13: After "manner", insert --with abrasive, to remove the Ta or TaN barrier layer, under conditions such that there is no or reversed selectivity among the silicon oxide interlayer dielectric, barrier layer and Cu.--

Column 9, Line 50: Change "none" to --one--

Column 10, Line 21: Delete the comma after "instructions"

Column 10, Line 21: After "initially", delete "be"

In the Claims

Column 11, Claim 16, Line 58: Before "a computer-readable", delete "comprise"

Column 12, Claim 18, Line 9: Change "iminodiaetic" to --iminodiacetic--

Column 12, Claim 23, Line 50: Change "of" to --is--

MAILING ADDRESS OF SENDER (Please do not use customer number below):

Keith M. Tackett PATTERSON & SHERIDAN, L.L.P. 3040 Post Oak Blvd., Suite 1500 Houston, TX 77056-6582

This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450, DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Attention Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.

